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	Application No.	Applicant(s)
Notice of Allowability	10/630,868	YANG, YUN-CHI
	Examiner	Art Unit
	David Nhu	2818
Th MAILING DATE of this communication appears on the cover she t with the corr spondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.		
1. X This communication is responsive to 7/31/03.		
2. 🔀 The allowed claim(s) is/are <u>1-15</u> .		
3. 🔀 The drawings filed on <u>31 July 2003</u> are accepted by the Examiner.		
4.		
Attachment(s)  1. ☑ Notice of References Cited (PTO-892)  2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)  3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date	6.  Interview Summary Paper No./Mail Dat 98), 7.  Examiner's Amendr	te
	Dai	12 Pa

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## **REASONS FOR ALLOWANCE**

1. Claims 1-15 are allowed.

2. The following is an examiner's statement of reasons for allowance: None of the references of record teaches or suggests in claims 1, 8: depositing a second oxide for covering the plurality of shallow trench isolations (STI) and active regions; etching the second ocide for forming a plurality of bird's beak spacers at the respective edges of the plurality of active regions (as cited in claim 1); forming a liner oxide on the trench and extending to an edge of the active region for intruding under the pad nitride to form a bird's beak; depositing a second oxide for covering the first oxide and active region; etching the second oxide for forming a bird's beak spacer at an edge of the active region (as cited in claim 8).

3. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

## CONCLUSION

- 4. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure: Kunikiyo (6,495,424 B2): Semiconductor Device.
- 5. Any inquiry concerning this communication on earlier communications from the examiner should be directed to David Nhu, (571)272-1792. The examiner can normally be reached on Monday-Friday from 7:30 AM to 5:00 PM.

The examiner's supervisor, David Nelms can be reached on (571)272-1787.

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The fax phone number for the organization where this application or proceeding is assigned is (703) 872-9306.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

David Nhu

Del

June 16, 2004

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